

# Combination Effect of Transition Metal Impurities on Oxygen Vacancy Formation Energetics in TiO<sub>2</sub>

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**Abstract**—The combination effect of substitutional impurities of group IVB–VIB transition metals on the oxygen vacancy formation energy in rutile titania was studied by the projector augmented wave method within density functional theory. The pair interaction energy of impurity atoms was estimated depending on the interatomic distance. It was shown that the interaction in the Zr+Zr, Hf+Hf and Nb+Ta pairs leads to the energy preference of their orientation along the  $\langle 100 \rangle$  direction at a distance of the lattice parameter  $a$ . The Mo+Mo and Nb+Mo pairs prefer to orient along the  $[001]$  direction at a distance of the lattice parameter  $c$ . If the impurity atoms are farther than the third neighbors, then their interaction can be neglected. It was found that the change in the oxygen vacancy formation energy due to doping with several impurities can be estimated as the sum of the energy changes due to single impurity divided by a coefficient whose value depends on the mutual arrangement of the impurity atoms.

**Keywords:** TiO<sub>2</sub> oxide, doping, oxygen vacancy, impurity combination, density functional theory

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## 1. INTRODUCTION

It is a common knowledge that doping and surface modification of TiAl-based alloys makes them attractive for use in aircraft engines, as components of gas turbines operating at temperatures up to 800°C, and in other fields [1–3]. An insufficient resistance of TiAl to oxidation is one of the key factors that reduces the service life and limits the operating temperature of the alloy parts [3–6]. It was experimentally found that the addition of a third component, such as Nb, Mo, W, or Re, improved the oxidation resistance of the TiAl alloy [7–11], while Mn and Cu worsened it [10–12]. Since experimental results are sensitive to many factors, such as temperature, partial pressure of oxygen, specimen purity, etc., the experiments often lead to contradictory conclusions. For example, such alloying elements as Cr, Ag, Hf, and Ta can be useful or undesirable from the corrosion resistance standpoint [9, 10, 13, 14]. The positive effect of the alloying elements on the oxidation resistance of TiAl alloy was explained by various factors: slowed diffusion of O in TiO<sub>2</sub> [14, 15], decreased solubility of Al in TiO<sub>2</sub> [11, 16], formation of a barrier layer on the surface or

at the interface [14, 17], suppressed internal oxidation in the alloy [14, 18], and others. However, none of the proposed mechanisms is universal, and it is quite difficult to experimentally determine the key factors influencing the oxidation resistance of titanium alloys. Although the found mechanisms allow a specific selection of alloying elements, the selection criteria are vague due to the lack of the direct relation to fundamental parameters. Therefore, theoretical studies of physicochemical and mechanical properties of titanium aluminides remain relevant.

Currently, there are a large number of theoretical works devoted to the effect of impurities on the oxidation resistance of TiAl-based alloys. For example, the adsorption of oxygen on undoped and doped low-index TiAl alloy surfaces was studied in [19–25]. It was shown that, regardless of the surface orientation, oxygen was mainly adsorbed in titanium-rich positions, which favored the formation of TiO<sub>2</sub>. With increasing oxygen concentration, O–Ti interactions compete with O–Al ones. Adhesive properties at the oxide–TiAl interface, as well as the influence of impurities and intermediate metal layers on its strength

characteristics, were studied in [26–32]. It was shown [26] that the addition of Nb caused oxygen atoms to displace from the oxide region to the alloy with the formation of O–Al bonds. This was taken as a proof of an increased interaction of oxygen with aluminum, responsible for the improvement of oxygen resistance of the alloy. The authors of [26–29] suggested that adhesion at an ideal interface was governed by the formation of O–Al bonds, while the authors of [30, 31] thought that the O–Ti interaction was the key factor. In [32], it was found that intermediate metal layers formed during segregation of the alloying element decreased adhesion, which however was quite high at the metal–oxide interface. Experimental works [33, 34 and references therein] revealed an increase in the oxidation resistance of TiAl alloy due to the formation of the  $Ti_5Si_3$  phase at the interface. The diffusion coefficient of oxygen in  $Ti_5Si_3$  was first calculated by theoretical methods in [35]. It was shown that this compound slowed down the diffusion of oxygen to rates characteristic of protective oxides such as  $Al_2O_3$  or  $SiO_2$ . However, the authors of [36] pointed to the negative effect of the brittle  $Ti_5Si_3$  phase at the interface. The influence of transition metal impurities on the energy of formation of  $Al_2O_3$  and  $TiO_2$  oxides, as well as the energy of formation of oxygen vacancies in the latter, was studied in [37]. It was discovered that Zr, Nb, Mo, Hf, Ta, W and Re impurities reduced the stability of  $Al_2O_3$  as compared to that of  $TiO_2$ . Moreover, these impurities increased the oxygen vacancy formation energy in  $TiO_2$ . Based on these effects, we can conclude that these impurities have a positive influence on the oxidation resistance of TiAl alloy.

The theoretical works noted above allowed significant advances in the understanding of fundamental principles of TiAl oxidation. However, the question of the influence of impurities on the oxygen vacancy formation in  $TiO_2$  remains open since only one configuration of the impurity–vacancy complex was studied [37]. It is known that impurities can suppress or, on the contrary, stimulate the formation of oxygen vacancies close and far from them. For example, the effect of impurities on oxygen sorption extends up to the fourth coordination sphere [38]. Though multi-component TiAl-based alloys are studied experimentally, their theoretical investigation remains difficult and requires large computational resources. The influence of two or more impurity atoms on the oxygen vacancy formation in oxides has not been studied by theoretical methods. Thus, the aim of this work is to study the combination effect of group IVB–VIB im-

purities on oxygen vacancy formation energetics in rutile  $TiO_2$ .

## 2. CALCULATION PROCEDURE

The atomic and electronic structures of ideal and defective titania with a rutile structure were calculated using the projector augmented wave (PAW) method in a plane-wave basis [39, 40] using the generalized gradient approximation for the Perdew–Burke–Ernzerhof (GGA–PBE) exchange–correlation functional [41]. The maximum energy of plane waves in the basis set was 400 eV. The  $TiO_2$  lattice parameters calculated in this work ( $a=0.4611$  nm,  $c=0.2956$  nm) differ from the experimental ones ( $a=0.4594$  nm,  $c=0.2959$  nm [42]) by less than 0.4%. The used supercell contained 216 atoms and measured  $3 \times 3 \times 4$  to exclude the interaction between defects from the adjacent cells. Relaxation of the atomic structure, including optimization of atom positions, cell shape and volume, was implemented by the conjugate gradient method. The convergence criterion with respect to forces acting on atoms was 0.001 eV/nm. Self-consistency of the electronic subsystem was calculated accurate to  $10^{-4}$  eV.

Since the formation energy of an O vacancy ( $V_O$ ) depends on the chemical potential of oxygen, which is difficult to assess, it is more convenient to calculate the doping-induced change in this energy:

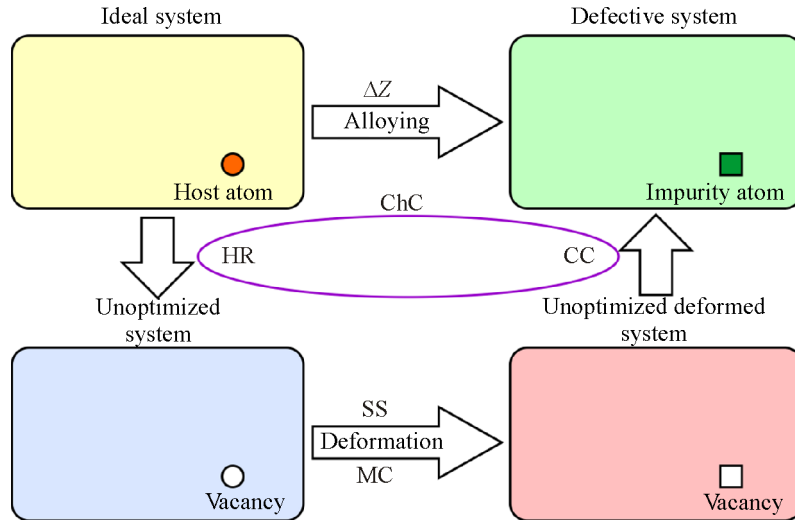
$$\Delta E_f = E_f^{\text{dop}} - E_f^{\text{id}} = E(TiO_2, V_O, X_{Ti}) - E(TiO_2, V_O) - E(TiO_2, X_{Ti}) + E(TiO_2), \quad (1)$$

where  $E_f^{\text{dop}}$  and  $E_f^{\text{id}}$  are the oxygen vacancy formation energies in the doped and undoped  $TiO_2$ ;  $E(TiO_2, V_O)$ ,  $E(TiO_2, X_{Ti})$ , and  $E(TiO_2, V_O, X_{Ti})$  are the total energies of an oxide supercell containing an oxygen vacancy, substitutional impurity, and both defects;  $E(TiO_2)$  is the total energy of the defect-free oxide. A positive (negative) value of  $\Delta E_f$  means that the impurity increases (decreases) the formation energy of oxygen vacancies, i.e. contributes to a decrease (increase) in their equilibrium concentration.

The pair interaction energy of impurity atoms is calculated by the formula

$$\Delta E_{\text{int}} = E(TiO_2, X_{Ti}, Y_{Ti}) - E(TiO_2, X_{Ti}) - E(TiO_2, Y_{Ti}) + E(TiO_2), \quad (2)$$

where  $E(TiO_2, X_{Ti})$ ,  $E(TiO_2, Y_{Ti})$ , and  $E(TiO_2, X_{Ti}, Y_{Ti})$  are the total energies of the oxide with one (X or Y) and two impurity atoms in the Ti sublattice. A positive value of  $\Delta E_{\text{int}}$  corresponds to repulsion between impurity atoms; a negative value, to attraction.



**Fig. 1.** Schematic of the method of decomposing the doping-induced change in the physical quantity  $\Delta Z$  into contributions (for explanation see the text) (color online).

According to the method proposed in [43], if impurities are substitutional, the change in the physical quantity  $Z$  presents the sum of the three contributions: the host removal (HR), substitutional structure (SS) and chemical + compressed impurity (CC) mechanisms:

$$\Delta Z = HR + SS + CC. \quad (3)$$

These contributions are schematized in Fig. 1. For ease of analysis, the first contribution responsible for breaking of old bonds and the third one associated with the formation of new bonds can be combined into the chemical contribution (ChC). The remaining SS contribution is associated only with structural deformation induced by impurity and can be regarded as the mechanical contribution (MC).

### 3. RESULTS AND DISCUSSION

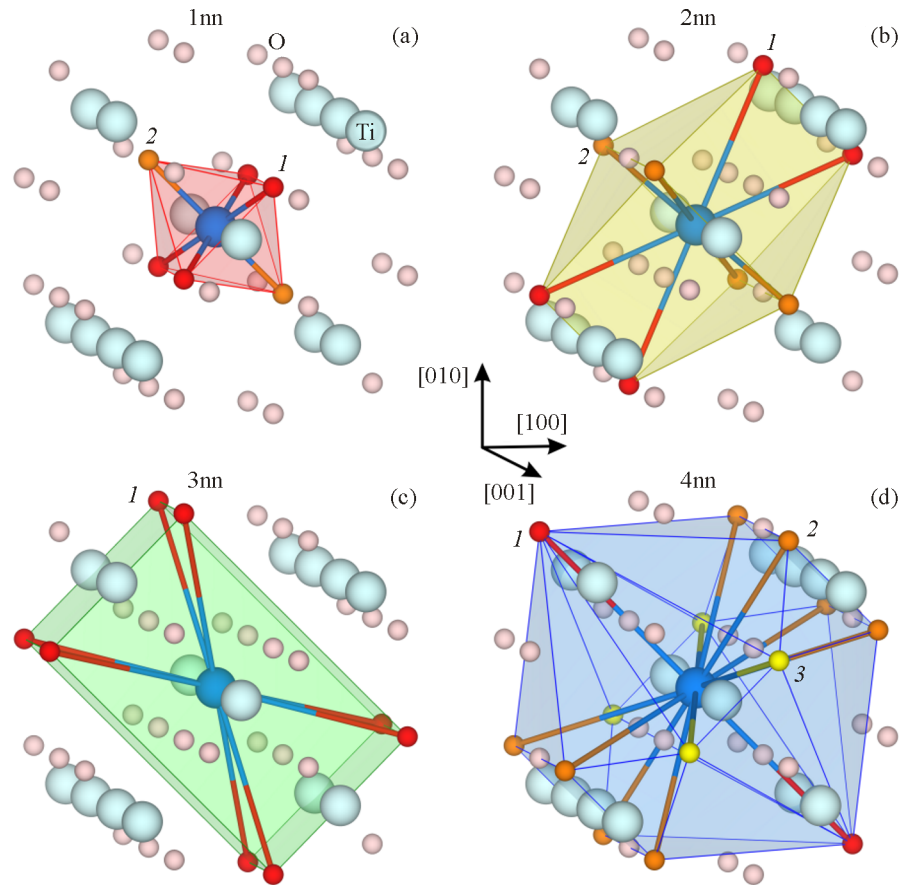
#### 3.1. Influence of Single Impurity on Oxygen Vacancy Formation Energy

As mentioned above, the energetics of formation of oxygen vacancies in doped titania was studied in [37]. It was shown that V and Cr impurities reduced the O vacancy formation energy, while metals isoelectronic with them and titanium, on the contrary, increased it. Investigation was given only to one position of the first-neighbor oxygen vacancies, without modeling vacancies farther from impurity atoms. As will be shown below, consideration for second- or third-neighbor impurities can lead to different conclusions.

Since the rutile lattice has a tetragonal structure, coordination polyhedra are circumscribed by ellip-

soids rather than coordination spheres. Let us number the coordination polyhedra in increasing order of the largest semi-axis of the circumellipsoid. Figure 2 shows the first four coordination polyhedra with oxygen atoms at the vertices and a titanium atom at the center. Oxygen atoms occupy 4f Wyckoff positions, which are displaced in the  $\langle 110 \rangle$  direction from the highly symmetrical configuration. Therefore, several positions differently spaced from the central titanium atom can be distinguished for them in each coordination polyhedron. Distances between oxygen atoms and the central titanium atom in these polyhedra are cited in Table 1. For example, each titanium atom in the first coordination polyhedron is coordinated by six oxygen atoms, four of which ( $1nn_1$ ) are located closer to the titanium atom, and two ( $1nn_2$ ) are farther (Fig. 2a and Table 1). The designation  $nn$  comes from the nearest neighbor term. The same is true for the second neighbors: four oxygen atoms ( $2nn_1$ ) are located slightly closer than the other four ( $2nn_2$ ) (Fig. 2b). Since the oxygen atoms of the third coordination polyhedron form a straight quadrangular prism with a titanium atom at its geometric center (Fig. 2c), all  $Ti-O_{3nn}$  interatomic distances are the same. Finally, in the fourth coordination polyhedron, oxygen atoms ( $4nn$ ) form a complex polyhedron and can be divided into three groups, as shown in Fig. 2d.

Figure 3 illustrates the change in the formation energy of an oxygen vacancy depending on its position relative to the impurity atom. It can be seen that almost all the impurities increase the energy of formation of both oxygen vacancies in the first coordination polyhedron, which is consistent with the early



**Fig. 2.** First four coordination polyhedra of oxygen atoms relative to the given titanium atom. Digits indicate the group of oxygen atoms belonging to the same coordination polyhedron but differently spaced from the given titanium atom (color online).

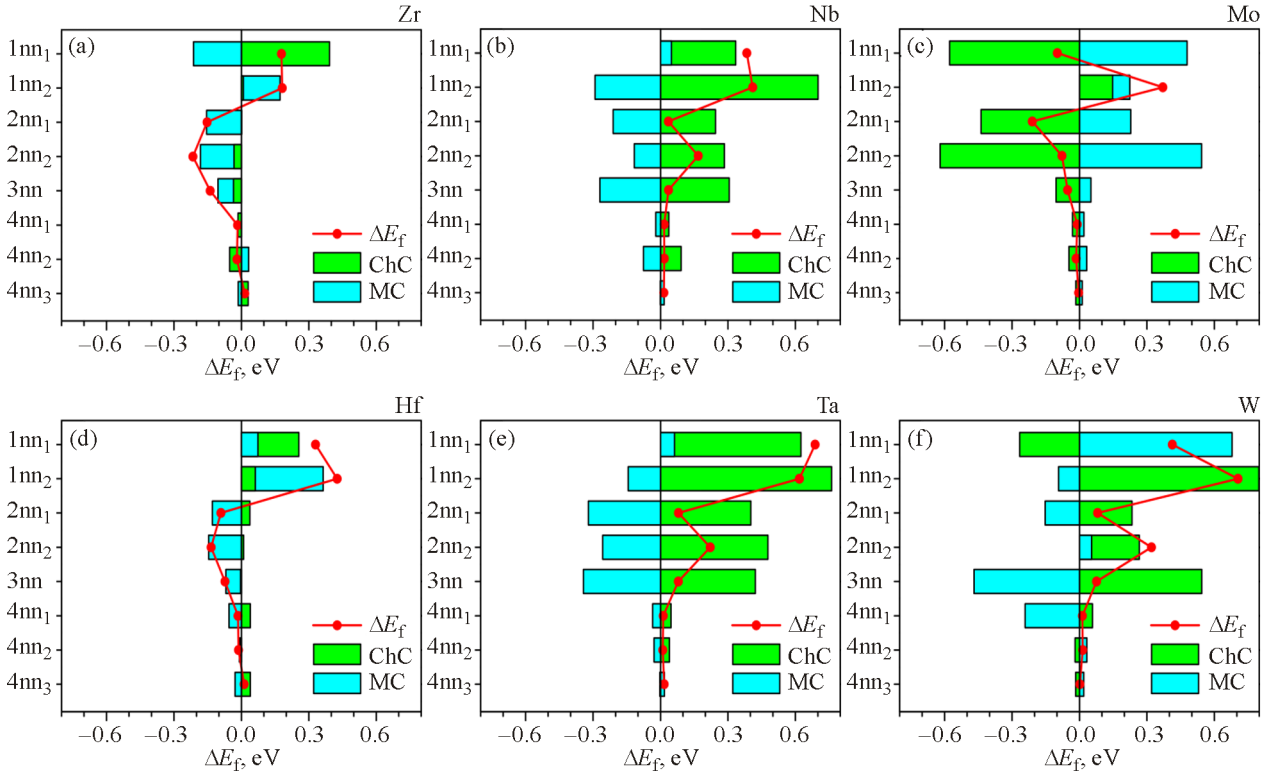
results [37]. However, the situation is more complex for more distant vacancies. For example, Zr, Hf, and Mo reduce the energy of formation of the second- and third-neighbor oxygen vacancies, while the other metals, on the contrary, increase it.

From Fig. 3 it is also clear that the  $E_f$  increase occurs by different mechanisms. Thus, when doping

with group IVB metals, the energy of formation of O vacancies in almost all positions changes due to the mechanical contribution (Figs. 3a, 3d). This is explained by the fact that these metals are isoelectronic with titanium, and the size factor plays the key role in changing  $E_f$ . The covalent radii of Zr and Hf are equal to 0.175 nm [44], being most different from the Ti radius (0.160 nm). The chemical contribution, i.e. the  $O_V-X_{Ti}$  interaction, dominates only for the 1nn<sub>1</sub> vacancy, closest to the impurity atom. As for group VB impurities, the absolute values of ChC and MC generally increase, through the key contribution is chemical (Figs. 3b, 3e). The decreasing role of the size effect is associated with similar covalent radii of Ti, Nb, and Ta (0.160, 0.164, and 0.170 nm [44]), and the increasing role of the chemical interaction is explained by a higher occupancy of the  $d$  shell of the VB group impurity atom. When doping with VIB impurities, the covalent radii of Mo (0.154 nm) and W (0.162 nm) are similar to the Ti radius, and therefore the  $E_f$  change is mainly determined by the chemical contribution (Figs. 3c, 3f). When a vacancy is located at the vertex of the fourth coordination

**Table 1.** Distances  $d$  between oxygen and titanium atoms and the number of oxygen atoms  $N$  at the vertices of the first four titanium coordination polyhedra

Coordination polyhedron	O atom group	$N$	$d(\text{Ti-O})$ , nm
1nn	1	4	0.197
	2	2	0.201
2nn	1	4	0.354
	2	4	0.358
3nn	1	8	0.414
4nn	1	2	0.458
	2	8	0.462
	3	4	0.464



**Fig. 3.** Change of the oxygen vacancy formation energy in TiO<sub>2</sub> due to doping with Zr (a), Nb (b), Mo (c), Hf (d), Ta (e) and W (f) impurities, as well as chemical and mechanical contributions to  $\Delta E_f$  (color online).

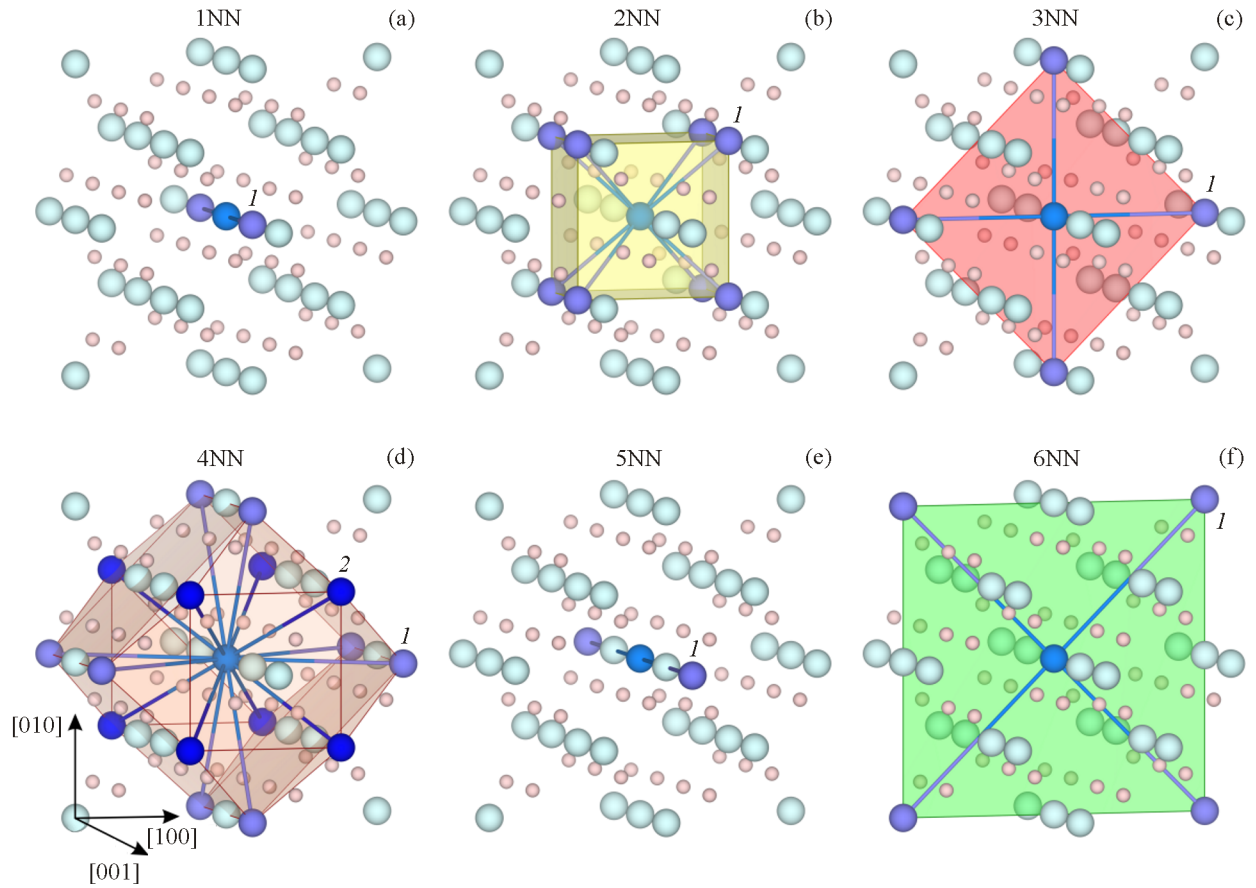
polyhedron, the absolute values of  $\Delta E_f$  do not exceed 0.02 eV. Thus, the impurity is assumed to affect the vacancy formation energy only within the first three coordination polyhedra.

### 3.2. Interaction between Impurity Atoms

Before proceeding to the combination effect of impurities on the oxygen vacancy formation energy in TiO<sub>2</sub>, it is necessary to determine energetically preferred structural configurations. For this purpose, the interaction energy between impurity atoms is calculated depending on the distance between them. Titanium atoms located at the vertices of the first six coordination polyhedra are shown in Fig. 4. Since titanium atoms are arranged in a body-centered tetragonal lattice with the ratio  $c/a < \sqrt{2/3}$ , the nearest neighbors are not eight atoms located in the cell vertices, as with a body-centered cubic structure, but two atoms of the neighboring cells in the direction  $\langle 001 \rangle$  (Fig. 4a). Coordination polyhedra with titanium atoms at the vertices and at the center will be denoted by capital NN. Figure 4b shows that the mentioned eight atoms correspond to the second coordination polyhedron. The third coordination polyhedron con-

tains four titanium atoms arranged in a square and located at the distance  $a$  from the given atom (Fig. 4c). The fourth coordination polyhedron includes two types of atoms: eight atoms at the distance equal to the diagonal of the lateral face of the rutile cell and eight atoms displaced from the given atom by  $a/2$  and  $3c/2$  (Fig. 4d). As can be seen from Fig. 4e, the fifth neighbors are two atoms located at the distance  $2c$  from the given atom. Interestingly, the sixth neighbor titanium atoms are also arranged in a planar configuration (Fig. 4f), like the 3NN atoms. Structural parameters of the coordination polyhedra are given in Table 2.

The calculations show that 3NN is energetically the most preferred configuration for pairs of impurity atoms isoelectronic with titanium, i.e. for Zr and Hf (Figs. 5a, 5d). This suggests that the interacting impurity atoms tend to form atomic chains in the  $\langle 100 \rangle$  direction. Group VB elements (Nb and Ta) have no tendency to form ordered structures in TiO<sub>2</sub> since  $\Delta E_{\text{int}} \geq 0$  in the considered configurations (Figs. 5b, 5e). Nevertheless, the smallest  $\Delta E_{\text{int}}$  also corresponds to the 3NN configuration. According to the calculations, Mo and W atoms are also prone to form chains, but in the  $[001]$  direction, since  $\Delta E_{\text{int}}$  is the most negative value in the 1NN configuration (Figs. 5c, 5f).



**Fig. 4.** First six coordination polyhedra of titanium relative to the given titanium atom. Digits indicate the group of titanium atoms belonging to the same coordination polyhedron but differently spaced from the given titanium atom (color online).

This tendency is much more pronounced for Mo ( $\Delta E_{\text{int}} = -0.93$  eV) than for W ( $\Delta E_{\text{int}} = -0.02$  eV). The interaction of the Nb and Mo impurity atoms stabilizes the 1NN structure (Fig. 5g). Though the Nb–Nb and Ta–Ta interactions result in no stable configurations, their combination (Nb+Ta) energetically prefers to form in the 3NN configuration (Fig. 5h).

When doping the oxide with Nb and W, no stable configurations are formed (Fig. 5i).

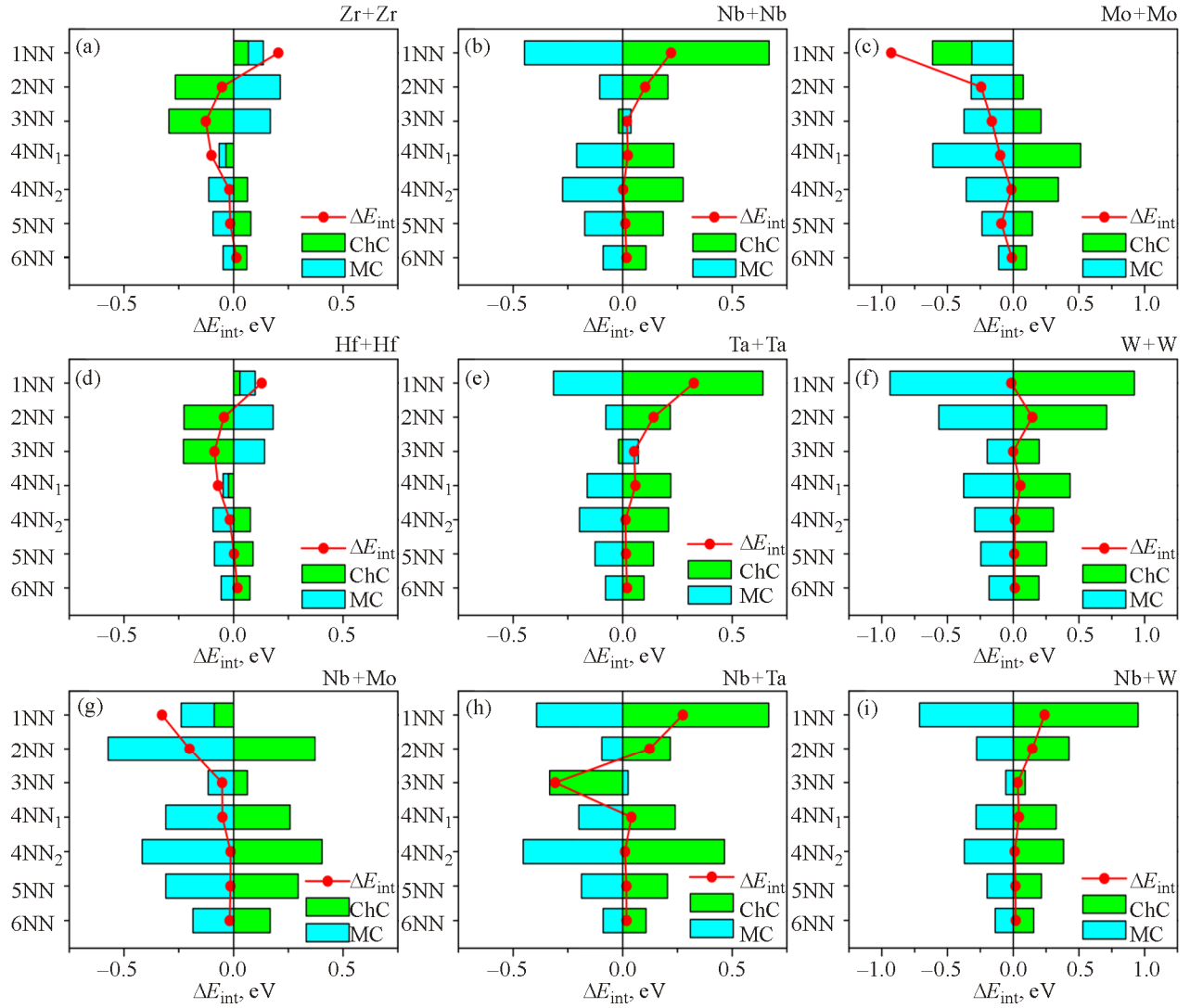
### 3.3. Influence of Two Impurity Atoms on Oxygen Vacancy Formation Energy

In the presence of two impurity atoms, an oxygen vacancy can form in two positions: (1) near (up to

**Table 2.** Distances  $d$  between titanium atoms in terms of lattice parameters, their values and the number of titanium atoms  $N$  at the vertices of the first six titanium coordination polyhedra

Coordination polyhedron	Ti atom group	$N$	$d(\text{Ti-Ti})$	$d(\text{Ti-Ti})$ , nm
1NN	1	2	$c$	0.2956
2NN	1	8	$0.5\sqrt{2a^2 + c^2}$	0.3579
3NN	1	4	$a$	0.4610
4NN	1	8	$\sqrt{a^2 + c^2}$	0.5476
	2	8	$0.5\sqrt{2a^2 + 9c^2}$	0.5503
5NN	1	2	$2c$	0.5912
6NN	1	4	$a\sqrt{2}$	0.6520





**Fig. 5.** Interaction energy between two impurity atoms in  $\text{TiO}_2$ , as well as chemical and mechanical contributions (color online).

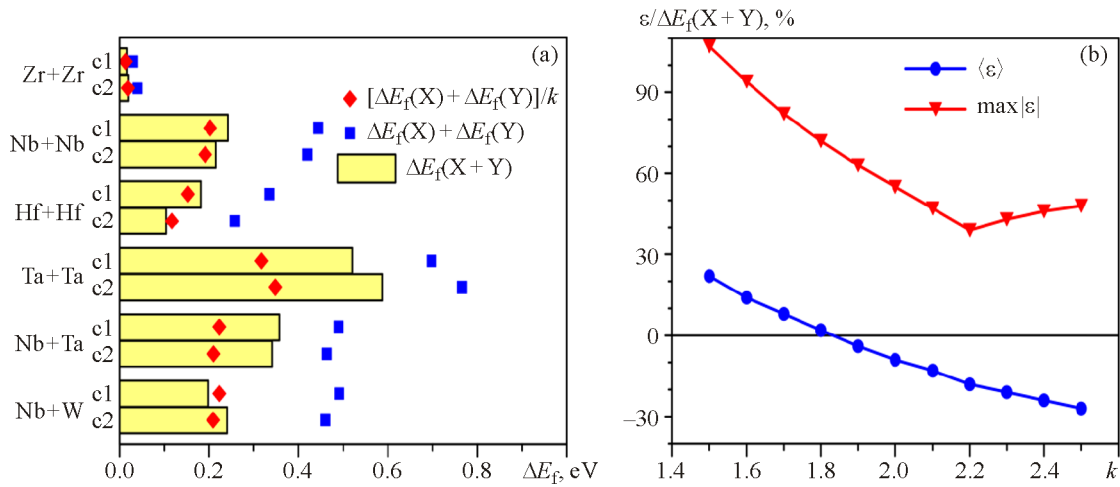
3nn inclusive) both impurity atoms, and (2) near one of the impurity atoms. In the first case, in the 3NN configuration of impurity atoms (Fig. 4c), a vacancy can be located in position  $1nn_2$  relative to one atom and position  $2nn_1$  relative to the other (c1) or in  $1nn_1$  and  $3nn$  (c2). In the second case, a vacancy can be in positions  $1nn_1$ ,  $1nn_2$ ,  $2nn_1$ ,  $2nn_2$  or  $3nn$  relative to one of the impurity atoms and more distant from the other. If impurity atoms are arranged in a 1NN structure (Fig. 4a), a vacancy, in the first case, can occupy position  $1nn_1$  (c1) or  $3nn$  (c3) relative to both impurity atoms as well as positions  $1nn_2$  and  $2nn_2$  (c2). In the second case, a vacancy has the same positions as in the 1NN configuration, except for position  $1nn_2$ .

Changes in the formation energy of oxygen vacancies ( $\Delta E_f(X_{\text{Ti}} + Y_{\text{Ti}})$ ) in the mentioned positions

are shown in Fig. 6a. It is also interesting to compare the effect of double impurity with the data obtained for the respective single impurities, i.e. the additive effect  $\Delta E_f(X_{\text{Ti}}) + \Delta E_f(Y_{\text{Ti}})$ , which is shown by blue squares in Fig. 6a. For convenience, the difference between these changes will be denoted as  $\varepsilon$ :

$$\varepsilon = \Delta E_f(X_{\text{Ti}}) + \Delta E_f(Y_{\text{Ti}}) - \Delta E_f(X_{\text{Ti}} + Y_{\text{Ti}}). \quad (4)$$

It was earlier found [38] for  $\text{Ti}_3\text{Al}$  alloy that the change in oxygen absorption energy near two impurity atoms can be accurately estimated as the sum of changes caused by the single impurities ( $\varepsilon < 0.11$  eV or  $< 9\%$  of the true value). However, judging from Fig. 6a, this does not hold for the oxygen vacancy formation energy in the oxide: the estimated values are significantly (1.5–2 times) higher than the true

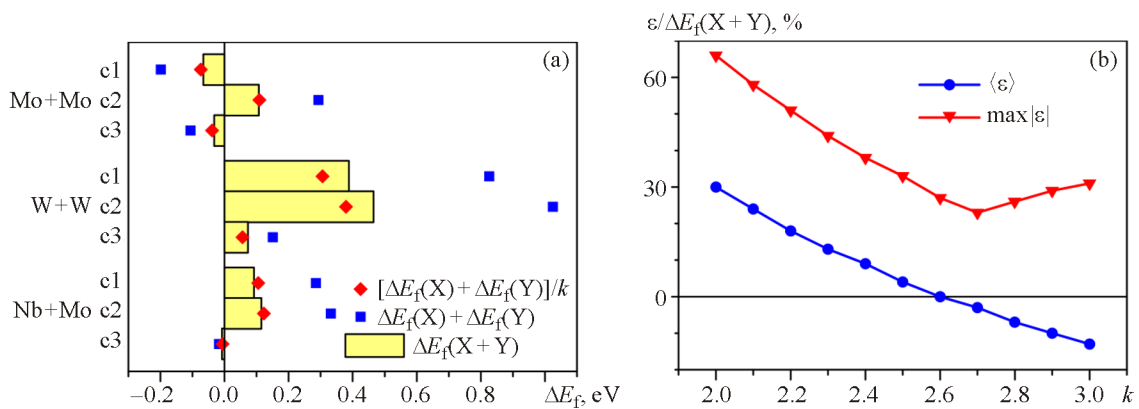


**Fig. 6.** Change of the oxygen vacancy formation energy in positions c1 and c2 near two impurity atoms in the 3NN configuration (a), dependence of the average and maximum absolute values of the parameter  $\varepsilon$  on the weakening coefficient  $k$  (b) (color online).

ones. This may be due to the fact that the oxide (insulator) is capable of a long-range contribution to the interaction energy due to weaker shielding compared to the alloy (conductor). Assuming that the interaction between impurity atoms weakens the influence of each impurity, the weakening coefficient  $k$  can be empirically chosen. Figure 6b plots the ratios of the average and maximum absolute values of  $\varepsilon$  to the true  $\Delta E_f(X_{Ti} + Y_{Ti})$  as a function of the parameter  $k$ . Averaging is carried out over all impurity pairs with the preferred 3NN configuration. It can be seen that, at  $k=2.2$ , the maximum deviation is 39%, which is the absolute minimum for this model. The maximum deviation is obtained for the Ta+Ta and Nb+Ta pairs with c1 and c2 vacancies, which corresponds to 0.22 and 0.13 eV. At  $k=2.2$ , the change in the oxygen vacancy formation energy is underestimated, on

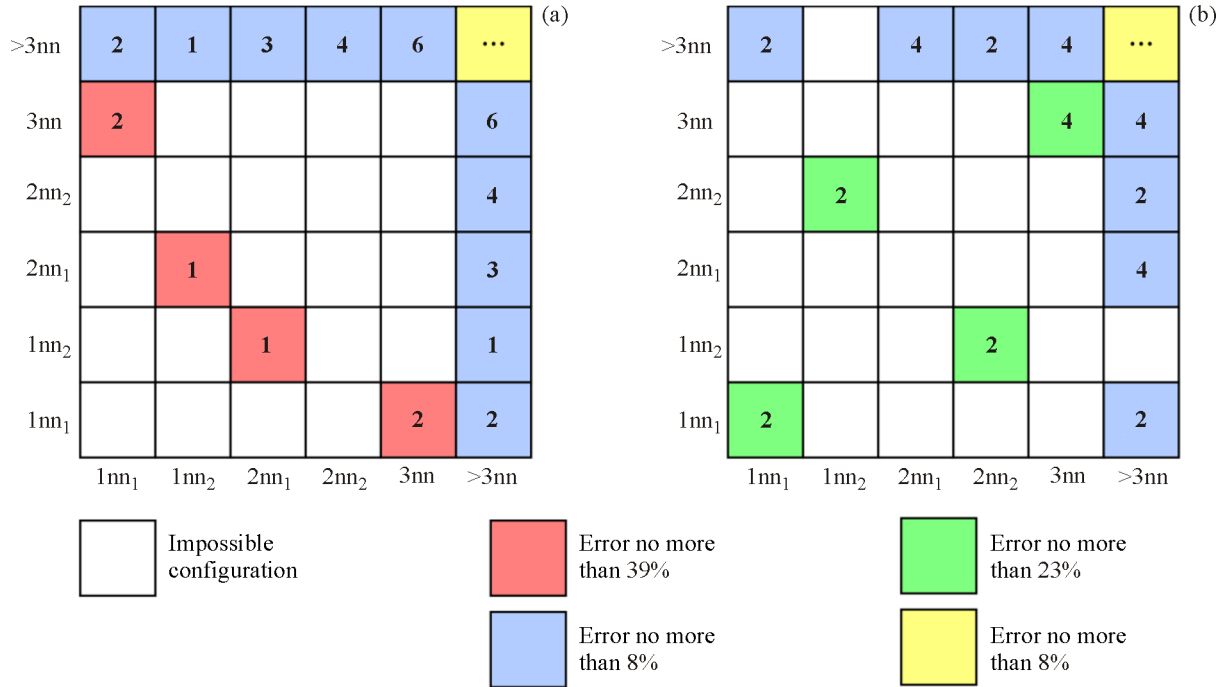
the average, by 18% or 0.06 eV. In the undoped oxide, the oxygen vacancy formation energy is 4.3 eV [37]. Thus, the maximum deviation of the adjusted estimated energy of oxygen vacancy formation from its true value does not exceed  $\sim 5.5\%$ . The  $\Delta E_f$  values estimated with consideration for the weakening coefficient are shown in Fig. 6a by red rhombs.

The simple additive model of the influence of impurities is also inapplicable to the Mo+Mo, W+W and Nb+Mo pairs with the preferred 1NN configuration (Fig. 7a). The weakening parameter is adjusted by minimizing the maximum deviation, resulting in the value  $k=2.7$  (Fig. 7b). In this case, the maximum deviation is 23%, which corresponds to  $-0.007$ ,  $-0.017$ , and  $0.002$  eV for the Mo+Mo, W+W and Nb+Mo pairs with a c3 vacancy. The maximum absolute deviation is 0.08–0.09 eV (18–21%), which is



**Fig. 7.** Change of the oxygen vacancy formation energy in positions c1, c2, and c3 near two impurity atoms in the 1NN configuration (a), dependence of the average and maximum absolute values of the parameter  $\varepsilon$  on the weakening coefficient  $k$  (b) (color online).





**Fig. 8.** Schematic representation of possible positions of an oxygen vacancy in TiO<sub>2</sub> relative to a pair of impurity atoms in the 3NN (a) and 1NN configurations (b). Digits in the squares indicate the number of configurations (color online).

obtained for the W+W pair with c1 and c2 vacancies. Thus, the error of the  $\Delta E_f$  estimation for these impurity pairs is comparable to the calculation error of the interaction energy between impurity atoms.

If a vacancy is farther from the impurity atom than the third neighbors, the deviation of the estimated  $\Delta E_f$  from the true values is small and does not exceed 8% in the 3NN and 1NN configurations of impurity atoms. The crystal volume can be divided into several regions depending on the vacancy position relative to a pair of impurity atoms. For illustration, these regions are marked with different squares in Fig. 8: white squares correspond to impossible combinations of V<sub>O</sub> with X<sub>Ti</sub> and Y<sub>Ti</sub>; red and green, to case 1; blue, to case 2; yellow, to vacancy positions far from both impurities.

In conclusion, it may be said that the oxygen diffusion coefficient in doped TiO<sub>2</sub> can be estimated based on the average energies of oxygen vacancy formation and migration along each of the three possible paths (see, for example, [45, 46]). The first characteristic should be calculated with consideration for the number of positions near both impurities, near one of them, and far from both (digits in Fig. 8). To find the second characteristic, it suffices to know the energies of oxygen vacancy migration between the red (green) and blue regions or within them. As was shown in

[47] for hydrogen, the change in the migration energy along other paths can be neglected.

#### 4. CONCLUSIONS

The influence of two substitutional atoms (Zr, Nb, Mo, Hf, Ta, W) on the oxygen vacancy formation energy in rutile TiO<sub>2</sub> depending on their relative position was studied by the projector augmented wave method. It was shown that the substitution of a Ti atom increased the oxygen vacancy formation energy by 0.1–0.7 eV for the first-neighbor vacancies relative to the impurity atom. The mechanism of this effect depends on the group of the impurity element in the periodic table. If a vacancy was located at the vertex of the second or third coordination polyhedron, then only Zr, Hf and Mo impurities reduced  $E_f$  by 0.1–0.2 eV. In the case of the first two impurities, this was mainly due to the mechanical contribution. The replacement of a titanium atom with a larger one partially compensated for the lattice compression during vacancy formation. When doping with molybdenum, the  $E_f$  decrease was caused mainly by the chemical contribution, although there was no direct impurity–vacancy interaction. If the vacancy was farther than the third neighbors of the impurity atom, then the influence of the latter can be neglected, since

the absolute value of their interaction energy did not exceed 0.02 eV.

The interaction energy between two impurity atoms was estimated depending on their position. It was shown that the Zr–Zr, Hf–Hf and Nb–Ta interaction stabilized the 3NN configuration when the impurity atoms were the third neighbors of each other. The interaction energy in the Mo+Mo and Nb+Mo pairs reached its lowest value in the 1NN configuration. Change in the oxygen vacancy formation energy caused by the interaction with two impurity atoms can be estimated as the sum of the changes due to single impurities with consideration for the weakening coefficient. By minimizing the maximum deviation of the estimated  $\Delta E_f$  from the true value, the weakening coefficient (2.2 and 2.7) was found for the 3NN and 1NN configurations of impurity atoms. In the first case, the estimation error did not exceed 0.09 eV (18%), while, in the second case, the maximum error was 0.22 eV (39%) for the Ta+Ta pair. Thus, this method makes it possible to estimate the influence of several impurities on the vacancy formation energy. This saves computing resources, by determining the most promising impurity combinations for accurate calculations.

#### FINDING

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#### CONFLICT OF INTEREST

The authors of this work declare that they have no conflicts of interest.

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